Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/672,880	BISKEBORN ET AL.	
Examiner	Art Unit	
Paul D. Kim	3729	

		 			
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Class	Subclass	Date	Examiner		
29	417 603.11 603.13- 603.16	6/12/2006	PK		
	603.18				
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SEARCH NO (INCLUDING SEARCI)
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Reviewed Parent Application 09/877382 (US PAT. 6,646,830)	6/12/2006	PK
Text Search EAST/NPL (IEEE)	6/12/2006	PK